

PATENT
0051-0217P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KOJIMA, Tomoyuki et al. Conf.:
Appl. No.: New Group:
Filed: January 16, 2004 Examiner:
For: VACUUM SUCTION SYSTEM AND METHOD OF
CONTROLLING THE SAME

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 16, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This amendment includes Amendment to the Specification; and
Remarks.